

Attorney Docket No. OMY-0006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Kenichi Okubo

Application No.: 10/706,817

Confirmation No.: 5954

Filed: November 7, 2000

Art Unit: 2851

For: SUBSTRATE PROCESSING APPARATUS
AND SUBSTRATE PROCESSING METHOD

Examiner: Alan A. Mathews

Commissioner for Patents
Alexandria, VA 22313

Via Facsimile 703-746-9195

REQUEST FOR CORRECTED FILING RECEIPT

1. Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested. We are enclosing a copy of the declaration that was filed on November 7, 2000 which shows the correct title.
2. There is an error with respect to the following, which is incorrectly entered.

| | |
|-----------------------|--|
| <i>Error In</i> | <i>Correct data</i> |
| 1. Title of Invention | 1. SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD |
3. The correction is not due to any error by applicant and no fee is due. However, if any costs are involved, please charge Deposit Account No. 18-0013.

Respectfully submitted,

Dated: October 8, 2004

Tel. No.: (202) 955-3750



Robert S. Green, Reg. No. 41,800
Rader, Fishman & Grauer, PLLC
1233 20th Street, N.W., Suite 501
Washington, DC 20036
Customer No.: 23353

BEST AVAILABLE COPY



UNITED STATES PATENT AND TRADEMARK OFFICE

COMMISSIONER FOR PATENTS
UNITED STATES PATENT AND TRADEMARK OFFICE
WASHINGTON, D.C. 20231
www.uspto.gov

| APPLICATION NUMBER | FILING DATE | GRP ART UNIT | FIL FEE REC'D | ATTY. DOCKET NO. | DRAWINGS | TOT CLAIMS | IND CLAIMS |
|--------------------|-------------|--------------|---------------|------------------|----------|------------|------------|
| 09/706,817 | 11/07/2000 | 2812 | 950 | OMY-006 | 11 | 14 | 6 |

23353
RADER FISHMAN & GRAUER PLLC
LION BUILDING
1233 20TH STREET N.W., SUITE 501
WASHINGTON, DC 20036

FILING RECEIPT



OC000000006722977

Date Mailed: 01/31/2001

Receipt is acknowledged of this nonprovisional Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Customer Service Center. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the PTO processes the reply to the Notice, the PTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Kenichi Okubo, Kikuchi-Gun, JAPAN;
Akira Kanbayashi, Kikuchi-Gun, JAPAN;

Continuing Data as Claimed by Applicant

Foreign Applications

JAPAN 11-321735 11/11/1999

BEST AVAILABLE COPY

If Required, Foreign Filing License Granted 01/31/2001

Title

Substrate processing apparatus and substrate processing method

Processing

Preliminary Class

438

Data entry by : GARNETT, SANDRA

Team : OIPE

Date: 01/31/2001

10706817 11/07/2000 2812 950 OMY-006 11 14 6